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APPLICANTS

Wei Liu, San Jose, CA;

David Mui, Fremont, CA;

** CONTINUING DATA ***** *BK, none*** FOREIGN APPLICATIONS ***** *BK, none*

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>BK</i> Examiner's Signature Initials	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 1
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ADDRESS
PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. Box 450A
Santa Clara, CA
95052

TITLE

Method of controlling critical dimension microloading of photoresist trimming process by selective sidewall polymer deposition

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